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APPLICANTS

Shoriki Narita, Hirakata-shi, JAPAN;  
 Masahiko Ikeya, Sakai-shi, JAPAN;  
 Yasutaka Tsuboi, Hirakata-shi, JAPAN; Takaharu Mae, Hirakata-shi, JAPAN;  
 Shinji Kanayama, Kashihara-shi, JAPAN;

*SC*  
 \*\* CONTINUING DATA \*\*\*\*\*

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35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>SC</i> 12/23/04	EXAMINER'S SIGNATURE <i>SC</i>	INITIALS <i>SC</i>		

ADDRESS  
 000513  
 WENDEROTH, LIND & PONACK, L.L.P.  
 2033 K STREET N. W.  
 SUITE 800  
 WASHINGTON, DC  
 20006-1021

TITLE  
 Method and apparatus for correcting inclination of IC on semiconductor wafer

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of
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